

Atty. Dkt. No. 5298-08101  
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Title: SONOS STRUCTURE INCLUDING A DEUTERATED OXIDE-SILICON INTERFACE AND METHOD FOR MAKING THE SAME

**§**

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Pamela Gerik  
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Commissioner for Patents  
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The captioned application is a divisional application from prior application 10/094,108 filed May 8, 2002 pursuant to 37 C.F.R. § 1.53(b). Prior to initial examination of the captioned matter, please amend the case as follows:

**Amendments to the Title** begin on page 2 of this paper.

**Amendments to the Specification** begin on page 3 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks** begin on page 5 of this paper.

### **Amendments to the Title**

Please replace the title on the cover page of the specification with the following rewritten title.

SONOS STRUCTURE INCLUDING A ~~DUETERATED~~ DEUTERATED OXIDE-SILICON  
INTERFACE AND METHOD FOR MAKING THE SAME